



Docket No.: SON-1718
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yasukiyasu Sugano et al.

Application No.: 09/478,812

Filed: January 7, 2000

For: PROCESS FOR PRODUCING THIN FILM
SEMICONDUCTOR DEVICE AND LASER
IRRADIATION APPARATUS

Art Unit: 2815

Examiner: E. Lee

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SEP 02 2004

TECH CENTER 2000

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J. McQuinn
10/7/04

**PRELIMINARY AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED
EXAMINATION (RCE)**

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.